

Notice of References Cited	Application/Control No. 09/910,722	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner David Chung	Art Unit 2871	Page 1 of 1

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	B	US-6,025,835	02-2000	Aoki et al.	345/204
	C	US-6,396,468	05-2002	Matsushima et al.	345/87
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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